



843.37558VX1

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: M. FUNABASHI  
Application No.: 09/902,673  
Filed: July 12, 2001  
For: METHOD OF MANUFACTURING A SEMICONDUCTOR  
INTEGRATED CIRCUIT DEVICE  
Group: 2825  
Examiner: L. Malsawma

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DEC 11 2003  
TC 2800 MAIL ROOM

**AMENDMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

December 4, 2003

Sir:

In response to the Office Action mailed June 4, 2003, the period of response for which extension is requested by the attached Petition for Extension of Time, please amend the above-identified application as listed below, and as set forth on the following pages:

**Amendments to the Claims; and**

**Remarks are included following the amendments.**